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Ruth Montalvo Date: 04/13/05

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Docket No. GK-OEH-181 / 500814.20083

Applicant(s): Guido HERGENHAN, Christian ZIENER and Kai GAEBEL

Application No.: 10/788,609 Group: 2877

Filed: February 27, 2004 Examiner:

For: ARRANGEMENT FOR THE STABILIZATION OF THE RADIATION EMISSION OF A PLASMA

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SECOND INFORMATION DISCLOSURE STATEMENT**

SIR:

Applicant herewith submits this Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §§ 1.97 and 1.98 and hereby makes of record the following references listed below

	Document Number	Date	Name and/or Country
AL	WO 01/49086	07/05/2001	WIPO
AM	WO 02/32197	04/18/2002	WIPO
AV	<b>Review of Scientific Instruments, February 2003, Vol. 74, No. 2, pgs 969 – 974, Article: "Spatial characterizaion of extreme ultraviolet plasma generated by laser excitation of xenon gas targets" Sebastian KRANZUSCH, et al.</b>		

Accompanying this Information Disclosure Statement and form PTO-1449 are copies of the documents.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,

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Enclosures:  
PTO-1449  
3 documents



**LIST OF PRIOR ART CITED BY APPLICANT**  
**(Filed on April 13, 2005)**

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Applicant(s): Guido HERGENHAN, Christian ZIENER and Kai GAEBEL

Application No. 10/788,609

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Examiner:

**U.S. PATENT DOCUMENTS**

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES	NO
	AL	WO 01/49086	07/05/2001	WIPO			n/a	
	AM	WO 02/32197	04/18/2002	WIPO			n/a	
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							

**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

AV	Review of Scientific Instruments, February 2003, Vol. 74, No. 2, pages 969 – 974, Article: "Spatial characterizaion of extreme ultraviolet plasma generated by laser excitation of xenon gas targets" Sebastian KRANZUSCH, et al.
AW	
AX	
AY	
AZ	

Examiner:

Date:

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.